Adsorption and Reactions of ClCH₂CH₂OH on Clean and Oxygen-Precovered Cu(100): Experimental and Computational Studies

Tao-Wei Fu, Yung-Hsuan Liao, Chia-Yuan Chen, Pei-Teng Chang, Ching-Yung Wang, and Jong-Liang Lin*

Department of Chemistry, National Cheng Kung University 1, Ta Hsueh Road, Tainan, Taiwan 701, Republic of China

Received: May 4, 2005; In Final Form: August 18, 2005

Temperature-programmed reaction/desorption, reflection—absorption infrared spectroscopy, and density functional theory calculations have been employed to investigate the adsorption and thermal reactions of ClCH₂CH₂OH on clean and oxygen-precovered Cu(100) surfaces. On Cu(100), ClCH₂CH₂OH is mainly adsorbed reversibly. The ClCH₂CH₂OH molecules at a submonolayer coverage can change their orientation with increasing temperature. However, on oxygen-precovered Cu(100), all of the adsorbed ClCH₂CH₂OH molecules below 0.5 langmuir exposures completely dissociate to generate ethylene and acetaldehyde via the intermediate of ClCH₂CH₂O—. The computational studies predict that the ClCH₂CH₂O— is most likely to be adsorbed at the 4-fold hollow sites of Cu(100), with its C—O bond only slightly titled away from the surface normal and with a gauche conformation with respect to the C—C bond. The hollow-site ClCH₂CH₂O— has an adsorption energy that is 4.4 and 19.2 kcal·mol⁻¹ lower than that of the ClCH₂CH₂O— bonded at the bridging and atop sites, respectively. No significant effect of precovered oxygen on the ClCH₂CH₂O— bonding geometry and infrared band frequencies has been observed, as compared with the case without oxygen.

Introduction

For straight chain alkyl chlorides on Cu(100), it is found that C-Cl dissociation does not occur until the chain length reaches seven carbons. On the basis of the desorption temperature of chloropropane, chlorobutane, chloropentane, and chlorohexane and the assumption of a preexponential factor of 10¹³ s⁻¹ of first-order desorption kinetics, the heat of molecular adsorption is estimated to increase at a rate of 1.3 kcal·mol⁻¹ per CH₂ group. Chloroheptane decomposes on Cu(100), forming heptene at 250 K.¹ On Pd(111), chlorobutane is the shortest alkyl chloride to dissociate.2 Chloromethane does not dissociate on Al(111) and Pt(111).3,4 For ethanol on Cu(100), only a few percent of the adsorbed molecules at monolayer coverage can dissociate. However, ethanol readily decomposes by O-H bond scission on oxygen-precovered Cu(100) (O/Cu(100)) between 200 and 300 K, generating acetaldehyde as an end product.^{5,6} Alcohol molecules decompose by O-H bond scission on a large number of clean transition metal surfaces, such as Fe(110).⁷ Ni(110),⁸ Ni(100),⁹ Ru(0001),¹⁰ Mo(100),¹¹ Mo(110),¹² Rh-(111),¹³ Pd(111),¹⁴ and Pt(111).¹⁵

In the study of ClCH₂CH₂OH, with two reactive centers of C-Cl and C-OH, on Cu(100) and O/Cu(100), we are interested in the bond dissociation of ClCH₂CH₂OH, in the surface intermediates and their bonding geometry, in the reaction products, and in the effect of oxygen present on Cu(100). These subjects depend on the interaction between these two active centers and their interactions with the surface. Various surface intermediates are possibly generated from ClCH₂CH₂OH decomposition on Cu(100) and O/Cu(100), such as ClCH₂CH₂O-, HOCH₂CH₂O-, and OCH₂CH₂O-, which are determined by the C-Cl and O-H bond dissociation temperatures. Studies of these intermediates are

important in understanding the mechanisms of catalytic systems. Temperature-programmed reaction/desorption (TPR/D) and reflection—absorption infrared spectroscopy (RAIRS) have been employed to study the surface desorption and reactions. A program based on density functional theory (DFT) has been implemented to assist in the infrared analysis and in the prediction of the adsorption geometries for the surface intermediates generated from ClCH₂CH₂OH decomposition. It is found that only a small percentage of a monolayer ClCH₂CH₂-OH dissociates on Cu(100), generating C₂H₄ at 302 K, in contrast to the ClCH₂CH₂OH monolayer desorption at 213 K. The orientation of ClCH₂CH₂OH molecules in the adsorption layer on Cu(100) may vary with the surface temperature. The reactions of ClCH₂CH₂OH on O/Cu(100) at exposures ≤1 langmuir (1 L = 10^{-6} Torr·s) have been reported. In the present research, the ClCH₂CH₂OH exposure is extended to multilayer coverages. The RAIRS indicates that CICH2CH2OH dissociates on O/Cu(100) at 180 K, and the DFT calculations of infrared bands confirm the formation of a ClCH2CH2Osurface intermediate. This intermediate is predicted to be adsorbed at a 4-fold hollow site. TPR/D shows that the decomposition of ClCH₂CH₂O- evolves ethylene and acetaldehyde at temperatures higher than 275 K.

Experimental Section

All of the experiments were performed in an ultrahigh vacuum (UHV) apparatus equipped with an ion gun for sputtering, a differentially pumped mass spectrometer for TPR/D, four-grid spherical retarding field optics for low energy electron diffraction and Auger electron spectroscopy, and a Fourier transform infrared (FTIR) spectrometer for RAIRS. The chamber was evacuated by a turbomolecular pump and an ion pump to a base pressure of approximately $3\times 10^{-10}\,\mathrm{Torr}$. The quadrupole mass spectrometer used for the TPR/D study was capable of detecting

^{*} Corresponding author. E-mail: jonglin@mail.ncku.edu.tw.

ions in the 1-300 amu range and of being multiplexed to acquire up to 15 different masses simultaneously in a single desorption experiment. In TPR/D experiments, the Cu(100) surface was positioned ~ 1 mm from an aperture, 3 mm in diameter, leading to the mass spectrometer and a heating rate of 2 K/s was used. In the RAIRS study, the IR beam was taken from a Bomem FTIR spectrometer and focused at a grazing incidence angle of 85°, with respect to the surface normal, through a KBr window onto the Cu(100) in the UHV chamber. The reflected beam was then passed through a second KBr window and refocused on a mercury cadmium telluride detector. The entire beam path was purged with a Balston air scrubber for carbon dioxide and water removal. All of the IR spectra were taken at a temperature of about 115 K, with 800-1500 scans, and a 4 cm⁻¹ resolution. The presented spectra have been ratioed against the spectra of a clean Cu(100) surface recorded immediately before 2-chloroethanol dosing. The Cu(100) single crystal (1 cm in diameter) was mounted on a resistive heating element and could be cooled with liquid nitrogen to 110 K and heated to 1100 K. The surface temperature was measured by a chromel-alumel thermocouple inserted into a hole on the edge of the crystal. Cleaning of the surface by cycles of Ar⁺ ion sputtering and annealing was done prior to each experiment until no impurities were detected by Auger electron spectroscopy. 2-Chloroethanol (99%) was purchased from Riedel-deHaen and subjected to several freeze-pump-thaw cycles. Oxygen (99.998%) was obtained from Matheson. The purity of ClCH₂-CH₂OH was checked by mass spectrometry. The gas manifold for 2-chloroethanol was conditioned by backfilling with saturated 2-chloroethanol vapor pressure overnight. Prior to dosing 2-chloroethanol into the chamber, the gas manifold and 2-chloroethanol itself in the liquid state were pumped for a while.

The oxidized Cu(100) surface was prepared by exposing a clean Cu(100) surface at 500 K to 30 L of O₂, similar to the preparation for oxidized Cu(100) used in Sexton's study of alcohol.⁵ Atomic oxygen was present on the surface after the O₂ treatment, as verified by Auger electron spectroscopy and electron energy loss spectroscopy. It was estimated that the oxygen coverage for the oxidized Cu(100) used in this study was \sim 0.2 oxygen atoms per Cu atom ($\theta_0 = \sim$ 0.2).¹⁷ The previous study showed that a long range order started to develop at $\theta_0 = 0.34$ and a ($\sqrt{2} \times 2\sqrt{2}$)R45° structure was formed at a saturation coverage of $\theta_0 = 0.48$.¹⁷

In our calculations, the infrared spectra of ClCH₂CH₂OH and ClCH₂CH₂O— as well as the bonding geometries and relative energies of ClCH₂CH₂O— at different sites on Cu(100) were obtained by running a Cerius²-DMol³ module, ¹⁸ based on density functional theory, ¹⁹ in which a double-numerical quality basis set with polarizations, except 2p for hydrogen, and Perdew—Wang functional (PWC) for exchange and correlation were used. The double-numerical quality basis sets with polarizations were comparable to 6-31G** sets. However, the numerical basis set was much more accurate than a Gaussian basis set of the same size. The calculations were spin-unrestricted and did not include relativistic effects for the core electrons. Two-point frequency calculation with an integration accuracy of 10⁻⁶ were performed on fully optimized structures of ClCH₂CH₂OH and ClCH₂-CH₂O—.

Results and Discussion

Temperature-Programmed Reaction/Desorption of ClCH₂-CH₂OH on Cu(100). A multiple-ion TPR/D survey shows three desorption maxima at 185, 213, and 302 K, following ClCH₂-CH₂OH adsorption up to 15 L on Cu(100) at 115 K. The first

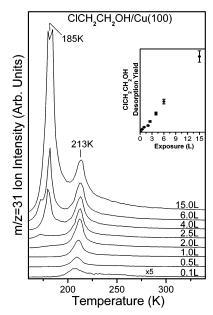


Figure 1. Temperature-programmed desorption spectra of a Cu(100) surface after dosing ClCH₂CH₂OH at different exposures. The ClCH₂-CH₂OH desorption is represented by the CH₂OH⁺ (m/z = 31) fragment. The 0.1 L trace is multiplied by a factor of 5. The inset shows the ClCH₂CH₂OH desorption yield vs exposure.

two states are due to ClCH₂CH₂OH molecular desorption from multilayer and monolayer, respectively, in contrast to the C₂H₄ desorption at 302 K. Figure 1 illustrates the exposure-dependent $ClCH_2CH_2OH$ desorption represented by the CH_2OH^+ (m/z =31) ion. At exposures ≤2 L, the highest ClCH₂CH₂OH desorption rate appears at 213 K. However, as shown in the 0.1 L trace, there is a small desorption feature at \sim 250 K, which is likely due to the ClCH₂CH₂OH molecules being more strongly adsorbed at defect sites. For ClCH2CH2OH exposures higher than 2 L, the 213 K peak gets saturated and a low temperature desorption state appears at ~185 K, which is attributed to ClCH₂CH₂OH multilayer desorption. Therefore, 2.0 L renders a monolayer coverage on a clean Cu(100) surface, that is, a saturated first layer coverage. In the inset of Figure 1, the linearly increased ClCH2CH2OH desorption yield versus exposure suggests that ClCH2CH2OH molecules are reversibly adsorbed within experimental error. However, there is a small amount C₂H₄ production confirmed by the C₂H₃⁺ ion, as shown in the TPR/D spectra of Figure 2. In Figure 2, except for the 180 and 213 K peaks originated from ClCH₂CH₂OH desorption, a new species is desorbed at 302 K and is identified to be C₂H₄ by the fragmentation pattern. Compared to the case of 0.5 L of ClCH₂CH₂OH on O/Cu(100) (shown later) in which the ClCH₂-CH₂OH completely decomposes, the C₂H₄ amount from 2 L of ClCH₂CH₂OH on Cu(100) is 4% of that from 0.5 L of ClCH₂-CH₂OH on O/Cu(100).

Reflection—Absorption Infrared Spectroscopy of ClCH₂-CH₂OH on Cu(100). Figure 3a shows the infrared spectrum taken after the adsorption of 4 L of ClCH₂CH₂OH on Cu(100) at 115 K. Note that a 4 L ClCH₂CH₂OH exposure renders a coverage of two monolayers. The infrared bands appear at 750, 850, 942, 1035, 1084, 1164, 1241, 1301, and 1436 cm⁻¹. A number of ClCH₂CH₂OH infrared studies regarding the absorption bands, vibrational mode assignment, conformational stability, and transition between the conformers have been reported. ^{20–29} In Table 1, the observed frequencies in Figure 3a are compared to those of ClCH₂CH₂OH measured in the gas state and to the calculated bands for three different ClCH₂CH₂OH conformers (Gg', Tg, and Tt) in the framework of density functional theory.

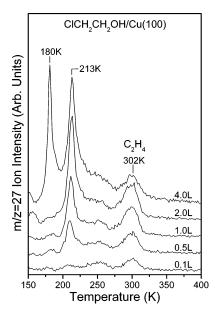


Figure 2. Temperature-programmed reaction/desorption spectra of a Cu(100) surface after dosing ClCH₂CH₂OH at different exposures. The 180 and 213 K peaks are due to ClCH2CH2OH desorption, in addition to C₂H₄ desorption at 302 K.

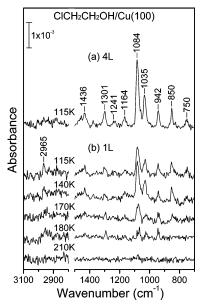


Figure 3. Reflection—absorption infrared spectrum of 4 L of CICH₂-CH₂OH adsorbed on Cu(100) at 115 K and reflection-absorption infrared spectra taken after exposing 1 L of ClCH₂CH₂OH to Cu(100) at 115 K and flashing the surface to the indicated temperatures.

The structures of the three ClCH2CH2OH conformers are displayed in Figure 4. The G and T represent gauche and trans ClCH₂CH₂OH forms, respectively, with respect to the C-C bond, in contrast to the g and t with respect to the C-O bond. Note that no scaling factor has been used for these computational frequencies and that the mode assignments are based on the animated vibrations of the corresponding bands. In the following analysis, the terms gauche and trans are used for the conformers with respect to the C-C bond. The infrared bands of ClCH2-CH2OH (Gg', Tg, and Tt) have been predicted by ab initio calculation utilizing the MP2/6-31G* basis set.²⁰ Our calculated frequencies based on the local DFT method are basically consistent with this previous theoretical report and with the measured gaseous ClCH2CH2OH infrared bands, as shown in Table 1. Accordingly, the present density functional calculations

can reliably assist not only in the vibrational mode assignments for the conformers of the adsorbed ClCH₂CH₂OH but also in the analysis of the ClCH2CH2OH surface reaction pathways through surface intermediate investigation. Gg' is the most stable conformer of ClCH₂CH₂OH and is the only form present in the crystal.²⁰ However, the vapor and liquid phases contain the Gg', Tt, and Tg forms. In the CICH2CH2OH vapor state, the number ratio of gauche/trans is ~3 at 25 °C.²⁸ The observed bands in the 4 L ClCH₂CH₂OH spectrum of Figure 3 are similar to those of gaseous ClCH2CH2OH, indicating that ClCH2CH2-OH is molecularly adsorbed on Cu(100) at 115 K. Furthermore, the gauche and trans ClCH₂CH₂OH coexist on the surface, judged by the mode assignments. The 750 cm⁻¹ band is due to the C-Cl stretching vibration of trans ClCH₂CH₂OH, and the 850 cm⁻¹ one is due to the rocking vibration of gauche ClCH₂-CH₂OH. The C-Cl stretching band of gauche ClCH₂CH₂OH is not measured because of our instrumental cutoff frequency at 700 cm⁻¹. Figure 3b shows the temperature-dependent spectra of 1 L of CICH₂CH₂OH on Cu(100). The 115 K spectrum is similar to that of 4 L in terms of band frequencies and relative intensities, indicating that ClCH₂CH₂OH molecules with gauche and trans forms are present on the surface at half monolayer coverage. The spectral feature starts to change after heating to 170 K. In the 180 K spectrum, the $750 \text{ and } 850 \text{ cm}^{-1}$ bands are not observed and the intensities of the 1035 and 1084 cm⁻¹ bands decrease significantly. Because no new bands appear, this spectral change is not attributed to ClCH2CH2OH decomposition. Although the possibility of ClCH2CH2OH desorption leading to partial decrease of peak intensities at 180 K cannot be completely ruled out, this effect may not be significant. Note that the onset temperature of ClCH₂CH₂OH desorption at a 1 L exposure is 190 K, as revealed in the TPR/D study. Therefore, the infrared change in intensity at 180 K is not attributed to ClCH₂CH₂OH desorption but mainly to the change of ClCH₂-CH₂OH adsorption orientation. In the 180 K spectrum, the 942 cm⁻¹ C-C stretching band of the Gg' form is comparable to that observed in the 115 and 140 K spectra. However, the 850 cm⁻¹ *CH₂ rocking band of Gg' ClCH₂CH₂OH is absent in the 180 K spectrum. Note that *C denotes the carbon which is bonded to the chlorine of ClCH2CH2OH. The combined RAIRS and TPD results suggest that the orientation of the adsorbed Gg' form varies due to the surface heating. Figure 5 shows a possible orientation change of the adsorbed gauche ClCH₂CH₂-OH from 115 to 180 K that explains the change of relative band intensities. The Figure 5b orientation can be achieved simply by rotating the Figure 5a molecule around the C-C axis. The band intensity of the C-C stretching mode (942 cm⁻¹) is not expected to be changed, according to the surface dipole selection rule of RAIRS, because the angle between the C-C bond and the surface is invariant. However, due to the rotation, the C-O bond becomes much more parallel to the surface, as shown in Figure 5b. Therefore, the C–O stretching intensity of 1084 cm⁻¹ is expected to be largely reduced in the Figure 5b orientation. A similar situation occurs in the case of the *CH₂ rocking mode. The dynamic dipole moment of *CH₂ rocking vibration in the surface normal direction for Figure 5b is much smaller than that for Figure 5a, leading to the disappearance of the 850 cm⁻¹ band in 180 K spectrum of Figure 3b. The bands of trans ClCH₂-CH₂OH on Cu(100) are also affected by the increase of surface temperature. In Figure 3b, the 750 cm⁻¹ C-Cl stretching band of trans ClCH2CH2OH is no longer observed at 180 K, suggesting also the change of adsorption orientation. As the adsorbed trans ClCH2CH2OH molecules adopt an orientation with their Cl-C-C-O backbone more parallel to the surface,

TABLE 1: Comparison of the Observed and Calculated Infrared Frequencies (cm⁻¹) of 2-Chloroethanol

	ClCH ₂ CH ₂ OH(g) ^b	local DFT calculation of ClCH ₂ CH ₂ OH (this work) ^{c,d}			
4 L of ClCH ₂ CH ₂ OH on Cu(100), 115 K (this work) ^a			Tg	Tt	
	673	658 ν(C-Cl)			
750 w	765		754 ν(C-Cl)	777 ν(C-Cl)	
850 w	853	855 $\rho(*CH_2)$	768 $\rho(*CH_2) + \rho(CH_2)$	812 ρ (*CH ₂)	
942 w	933	931 ν (C-C)	, , , , , ,	7	
			$1003 \rho(CH_2) + tw(*CH_2)$	991 ν(C-C)	
1035 m	1042	1033 tw(*CH ₂)	$1055 \nu (C-C)$	1035 tw(*CH ₂)	
	1056	. 2/	` '	. 2/	
1084 s	1078	$1102 \nu (C-O)$	$1085 \nu (C-O)$	$1120 \nu (C-O)$	
1164 w	1177	$1174 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	$1107 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	$1186 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	
	1201	$1186 \text{ tw}(*CH_2) + \text{tw}(CH_2)$	1227 ω(*CH ₂)	$1227 \ \omega(*CH_2) + \omega(CH_2)$	
1241 w		1267 ω(*CH ₂)	$1262 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	$1270 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	
1301 w	1292	. 27	. 27 . 27	$1288 \omega(*CH_2) + \omega(CH_2)$	
	1354	1342 tw(CH ₂)	1338 bending(COH)		
	1395	$1378 \omega(CH_2) + bending(COH)$	1361 ω (CH ₂) + bending(COH)	$1422 \omega(CH_2) + bending(COH)$	
1436 w	1436	$1414 \delta(*CH_2)$	1428 δ (*CH ₂)	1446 δ(*CH ₂)	
	1455	$1442 \delta(CH_2)$	$1451 \delta (CH_2)$	$1462 \delta (CH_2)$	
	2844	. 2/	. 27	$2864 \nu_{\rm s}({\rm CH}_2)$	
	2933	2903 $\nu_{\rm s} {\rm CH_2})$	2934 $\nu_{\rm s}({\rm CH_2})$	$2910 \nu_{a}(CH_{2})$	
		2,	2/	2916 $\nu_{\rm s}(*{\rm CH_2})$	
	2969	2996 $\nu_a(CH_2) + \nu_s(*CH_2)$	2992 $\nu_{\rm s}({\rm *CH_2})$	2983 $\nu_a(*CH_2)$	
	3013	$3007 \nu_s(*CH_2) + \nu_a(CH_2)$	$3033 \nu_{a}(CH_{2})$	2/	
		$3077 \nu_a(*CH_2)$	$3069 \nu_{a}(*CH_{2})$		
		3552 ν(O–H)	3627 ν(O-H)	3517 ν(O-H)	

 a w, weak; m, medium; s, strong. b From ref 20. c An asterisk denotes the CH₂ that is bonded to Cl. d ρ , rocking; tw, twisting; ω , wagging; δ , scissoring; ν_s , symmetric stretching; ν_a , antisymmetric stretching.

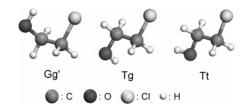


Figure 4. Three conformational isomers of ClCH₂CH₂OH.

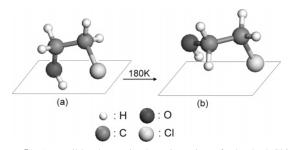


Figure 5. A possible change in the orientation of adsorbed ClCH₂-CH₂OH on Cu(100).

their C-O and C-Cl stretching intensities are expected to be reduced. It should be stressed that Figure 5 only demonstrates a plausible orientation change with temperature. The real orientation should be studied with other surface analytical techniques. In Figure 3b, as the surface is further heated to 210 K, no infrared bands are detected, which is consistent with the ClCH₂CH₂OH desorption observed in the TPR/D study.

Temperature-Programmed Reaction/Desorption of ClCH₂-CH₂OH on O/Cu(100). As oxygen atoms are present on Cu(100), the binding strength and thermal stability of ClCH₂CH₂-OH are perturbed. Figure 6 shows the spectra of ClCH₂CH₂OH desorption, represented by the CH₂OH⁺ ion, following ClCH₂-CH₂OH adsorption at different exposures. For an exposure ≤0.5 L, ClCH₂CH₂OH desorption is not found, indicating its decomposition on O/Cu(100). ClCH₂CH₂OH dissociates on O/Cu(100) between 170 and 220 K at a 0.5 L exposure. ¹⁶ As the exposure is increased to 1 L, the ClCH₂CH₂OH desorption appears at

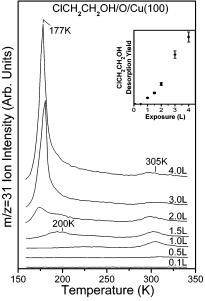


Figure 6. Temperature-programmed desorption spectra of a Cu(100) surface after dosing ClCH₂CH₂OH at different exposures. The ClCH₂-CH₂OH desorption is represented by the CH₂OH⁺ (m/z = 31) fragment. The inset shows the ClCH₂CH₂OH desorption yield vs exposure.

305 K. There are additional low-temperature desorption states at higher exposures. The inset of Figure 6 shows the ClCH₂-CH₂OH desorption yield as a function of exposure. Figure 7 shows the TPR/D spectra for the evolution of C_2H_4 , represented by the $C_2H_3^+$ ion, and CH₃CHO, represented by the CH₃CO⁺ ion, from ClCH₂CH₂OH decomposition on O/Cu(100). H₂O is also generated and desorbed at ~200 K (Figure 8).

Reflection—Absorption Infrared Spectroscopy of ClCH₂-CH₂OH on O/Cu(100). Figure 9 shows the temperature-dependent infrared spectra taken after the adsorption of 4 L of ClCH₂CH₂OH on O/Cu(100) at 115 K. The 115 K spectrum is similar to that of 4 L on Cu(100) at this temperature and is attributed to adsorbed ClCH₂CH₂OH. The 150 K spectrum

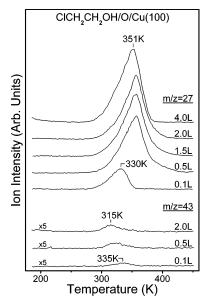


Figure 7. Temperature-programmed reaction/desorption spectra of a O/Cu(100) surface after dosing the indicated ClCH₂CH₂OH exposures at 115 K, collected for the C₂H₃⁺ and C₂H₃O⁺ ions, representative of C₂H₄ and CH₃CHO desorption, respectively.

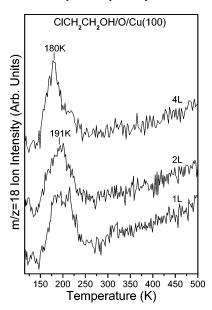


Figure 8. Temperature-programmed reaction/desorption spectra of H₂O evolution after dosing 1, 2, and 4 L of ClCH₂CH₂OH on O/Cu(100) at

resembles the 115 K one. However, the spectral feature changes at 180 K, with the obvious decrease in intensity of the 1034 and 1084 cm⁻¹ bands. This corresponds to the multilayer ClCH₂-CH₂OH desorption peaked at 177 K, as revealed in Figure 6. Furthermore, a new band at 1068 cm⁻¹ appears, suggesting that decomposition of ClCH2CH2OH proceeds together with desorption at 180 K. After heating the surface to 240 K, the peaks at 852, 1030, and 1068 $\rm cm^{-1}$ grow, as compared to the 180 K spectrum. The 1084 $\rm cm^{-1}$ band continues to decrease and becomes a shoulder of the $1068~\rm cm^{-1}$ band. In the $300~\rm K$ spectrum, the 1084 cm⁻¹ band disappears, showing further desorption and/or decomposition of ClCH2CH2OH. As the surface is heated to 320 K, only three bands at 847, 1021, and 1060 cm⁻¹ are observed. These three bands are no longer detected at 345 K which is the desorption temperature of C₂H₄ and CH₃CHO, as shown in Figure 7. Therefore, the species responsible for the bands of 847, 1021, and 1060 cm⁻¹ should

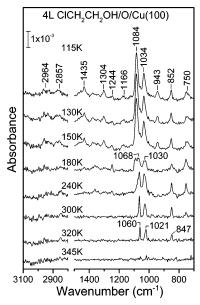


Figure 9. Reflection-absorption infrared spectra taken after exposing 4 L of ClCH₂CH₂OH to O/Cu(100) at 115 K and flashing the surface to the indicated temperatures.

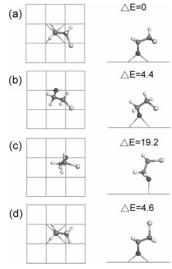


Figure 10. Optimized structures, with top and side views, of ClCH₂-CH₂O- adsorbed at the hollow (a), bridging (b), and atop (c) sites of Cu(100), respectively. Part d shows the ClCH₂CH₂O- structure with a trans conformation relative to the C-C bond. ΔE is the energy difference in kilocalories per mole for each structure relative to part a.

be the intermediate for the production of C₂H₄ and CH₃CHO. Temperature-dependent infrared investigations for 0.5, 1, and 2 L of ClCH₂CH₂OH on O/Cu(100) were also carried out and showed a similar changing behavior. The desorption products observed in the ClCH2CH2OH TPR/D studies can show some clues for the ClCH2CH2OH decomposition pathway and the surface intermediates generated on O/Cu(100). The H₂O desorption at ~200 K indicates the rupture of the O-H bond of ClCH₂CH₂OH. The C₂H₄ desorption indicates that the surface intermediate for this product contains the -CH₂CH₂- moiety. However, surface species such as -OCH₂CH₂O- and -CH₂-CH₂O-, which meet the TPR/D arguments, cannot account for the three bands at 847, 1021, and 1060 cm⁻¹. It has been reported that $-OCH_2CH_2O-$ on O/Cu(100) has two vibrational absorptions at 880 and 1090 cm⁻¹.30 -CH₂CH₂O- on O/Cu-(100), generated from 2.5 L BrCH₂CH₂OH dissociative adsorption, shows two strong bands of 1002 and 1059 cm⁻¹ at 260

TABLE 2: Structural Parameters of ClCH₂CH₂O-Adsorbed at Hollow, Bridging, and Atop Sites of Cu(100) (Figure 10a-c) and at Hollow Sites on O/Cu(100) (Figure 11)^a

	with O			
hollow	bridging	atop	hollow	
d(C-Cl) = 1.80	d(C-C1) = 1.83	d(C-C1) = 1.79	d(C-Cl) = 1.80	
d(C-C) = 1.49	d(C-C) = 1.49	d(C-C) = 1.50	d(C-C) = 1.49	
d(C-O) = 1.42	d(C-O) = 1.39	d(C-O) = 1.36	d(C-O) = 1.42	
$\theta(COS_N) = 3.6^{\circ}$	$\theta(COS_N) = 43.6^{\circ}$	$\theta(COS_N) = 52.2^{\circ}$	$\theta(COS_N) = 4.1^{\circ}$	
$\theta(CCS_N) = 69.3^{\circ}$	$\theta(CCS_N) = 56.8^{\circ}$	$\theta(CCS_N) = 21.1^{\circ}$	$\theta(CCS_N) = 71.4^{\circ}$	
$\theta(\text{CClS}_{\text{N}}) = 75.5^{\circ}$	$\theta(\text{CClS}_{\text{N}}) = 59.4^{\circ}$	$\theta(\text{CClS}_{\text{N}}) = 93.8^{\circ}$	$\theta(\text{CClS}_{\text{N}}) = 76.3^{\circ}$	
θ (OCC) =110.7°	θ (OCC) =113.4°	θ (OCC) =109.7°	θ (OCC) =111.0°	
θ (CCCl) =110.4°	θ (CCCl) =110.9°	θ (CCCl) =110.8°	θ (CCCl) =110.4°	
h(O) = 1.068	h(O) = 1.504	h(O) = 1.849	h(O) = 1.067	
			$h(O^*) = 0.587$	

 a d, bond length (Å); θ , bond angle; h, height from the Cu surface (Å); S_N , surface normal; O^* , adsorbed oxygen atom.

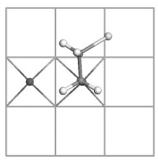
K.³¹ After exclusion of the possibility of $-OCH_2CH_2O-$ and $-CH_2CH_2O-$, the most likely intermediate is $ClCH_2CH_2O-$. To provide further support for the formation of this intermediate and to understand its adsorption geometry, density functional theory calculations have been employed to predict the $ClCH_2-$ CH₂O- infrared band frequencies and relative energies at different surface sites.

Theoretical Analysis of the Infrared Bands and Adsorption Geometry of ClCH₂CH₂O-. In our calculations for the adsorption geometry of ClCH2CH2O- on Cu(100), a slab of 16 Cu atoms fixed at their lattice positions was used. Figure 10a shows the most stable adsorption structure of ClCH₂CH₂O-(top and side views), obtained by minimizing the total energy. In the optimizing process, all of the bond lengths and angles of ClCH₂CH₂O-, including the C-Cu bond, were allowed to vary. Detailed structure information is shown in Table 2. There are several important structure features in this bonding geometry. ClCH₂CH₂O – is adsorbed at the 4-fold hollow site of Cu(100). The C-O bond of the ClCH₂CH₂O- is tilted away from the surface normal by 3.6°. The C-Cl bond of the ClCH₂CH₂Ois close to the surface. The ClCH₂CH₂O – basically has a gauche conformation with respect to the C-C bond. The optimized bonding geometries and total energies of ClCH₂CH₂O – bonded at bridging and atop sites were also calculated in order to compare to the hollow-site case. In these calculations, ClCH₂-CH₂O – was fixed at a bridging or atop site; however, all of the bond lengths and angles, including the distance between the O atom and the copper surface, were variable. The bonding structures of CICH2CH2O- at bridging and atop sites of Cu-(100) and their energies relative to the case of ClCH₂CH₂Oat hollow sites are shown in Figure 10b and c and Table 2. The ClCH₂CH₂O- bonded at these specific surface sites basically has a gauche conformation. The bridging and atop ClCH2-CH₂O – have adsorption energies 4.4 and 19.2 kcal·mol⁻¹ higher than the case of hollow-site adsorption, respectively. As ClCH₂-CH₂O is adsorbed with the trans conformation, our calculations predict that it has a higher adsorption energy than the gauche form. Figure 10d shows the optimized geometry of ClCH₂CH₂O-, with the trans conformation, at the hollow site and its relative energy. The trans ClCH₂CH₂O – has an energy 4.6 kcal·mol⁻¹ higher than the gauche ClCH₂CH₂O bonded at the hollow site of Cu(100).

Table 3 compares the calculated infrared band frequencies and the corresponding vibrational modes for the ClCH₂CH₂Oadsorbed at hollow, bridging, and atop sites, as shown in Figure 10. The calculated C-Cl stretching band of the trans ClCH₂-CH₂O – is 763 cm⁻¹ which is close to that of trans ClCH₂CH₂-OH and is much larger than those of gauche ClCH2CH2Olisted in Table 3. The experimental bands observed in the case of 4 L ClCH₂CH₂OH adsorption on O/Cu(100) followed by brief annealing to 320 K are also shown in the first column of Table 3 for comparison and for the support of ClCH₂CH₂O – generation from ClCH₂CH₂OH thermal decomposition. It is found that the 847, 1021, and 1060 cm⁻¹ bands are closely similar to the calculated band frequencies of gauche ClCH2CH2O- bonded at the hollow site of Cu(100), with a wavenumber difference $\leq 17 \text{ cm}^{-1}$. However, for the gauche ClCH₂CH₂O- at bridging and atop sites, their calculated C-O and/or C-C stretching frequencies at 1102 and 1107 cm⁻¹ are much larger than the observed 1060 cm⁻¹ band. The trans ClCH₂CH₂O- at the hollow site has no band near 847 cm⁻¹; therefore, it is not considered as the ClCH2CH2OH reaction intermediate with a right conformation. Note that the 4-fold hollow sites of Cu-(100) are predicted to be the most stable position for gauche ClCH₂CH₂O – adsorption, which is consistent with the closely

TABLE 3: Comparison of the Observed and Calculated Infrared Frequencies (cm⁻¹) of ClCH₂CH₂O- on Cu(100)

	DFT calculation of ClCH ₂ CH ₂ —						
4 L of CICH ₂ CH ₂ OH on O/Cu(100), 320 K	Cu(100) hollow site, gauche (Figure 10a)	Cu(100) bridging site, gauche (Figure 10b)	Cu(100) atop site, gauche (Figure 10c)	Cu(100) hollow site, trans (Figure 10d)	O/Cu(100) hollow site, gauche (Figure 11)		
	639 ν(C−Cl)	563 ν(C–Cl)	674 ν(C−Cl)	763 ν (C-Cl) 778 ρ (CH ₂) + ρ (*CH ₂)	630 ν (C-Cl) + ω (*CH ₂)		
847	833 in plane CCO bending + ρ(*CH ₂)	846 in plane CCO bending + ρ(*CH ₂)	864 in plane CCO bending + ρ(*CH ₂)		840 in plane CCO bending		
	929 $\rho(CH_2) + \omega(*CH_2)$	917 $\rho(CH_2) + \omega(*CH_2)$	922 $\rho(\mathrm{CH}_2) + \omega(\mathrm{*CH}_2)$	961 ν(C-O)	924 ρ(CH ₂)		
1021	1004 ν(C-O)	$1001 \text{ tw}(*\text{CH}_2) + \rho(\text{CH}_2)$	1025 ν(C-C)	$1015 \text{ tw}(*\text{CH}_2) + \rho(\text{CH}_2)$	1003 ν(C-O)		
1060	$1061 \nu(C-C) + \nu(C-C)$	$1102 \nu(C-O) + \nu(C-C)$	1107 ν(C-O)	1078 ν(C-C)	$1069 \nu(C-O) + \nu(C-C)$		
	//	$1141 \text{ tw}(*CH_2) + \text{tw}(CH_2)$	$1148 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	$1142 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$	$1160 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$		
	$1208 \text{ tw}(\text{CH}_2) + \nu(\text{C}-\text{C})$	$1201 \omega(*CH_2) + tw(CH_2)$	$1201 \text{ tw}(*\text{CH}_2) + \text{tw}(\text{CH}_2)$		$1211 \text{ tw}(CH_2) + \omega(*CH_2)$		
	$1270 \omega(*CH_2) + tw(CH_2)$	$1243 \ \omega(*CH_2) + tw(CH_2)$	1259 $\omega(*CH_2)$	$1241 \text{ tw}(CH_2) + \text{tw}(*CH_2)$	1262 ω (*CH ₂)		
	1321 ω (CH ₂)	1315 ω (CH ₂)	1285 ω (CH ₂)	$1315 \omega(CH_2) + \omega(*CH_2)$	1331 ω (CH ₂)		
	1381 δ (*CH ₂)	1385 δ (CH ₂)	1376 δ (CH ₂)	1412 δ (*CH ₂)	1391 δ (*CH ₂)		
	1419 $\delta(CH_2)$	1397 $\delta(*CH_2)$	1402 δ (*CH ₂)	$1440 \delta(CH_2)$	1405 δ (CH ₂)		
	2915 $\nu_{\rm s}({\rm CH_2})$	2657 $\nu_{\rm s}({\rm CH_2})$	2697 $\nu_{\rm s}({\rm CH_2})$	2938 $\nu_{\rm s}({\rm *CH_2})$	2913 $\nu_{\rm s}({\rm CH_2})$		
	2926 $\nu_{\rm s}({\rm *CH_2})$	2884 $\nu_{\rm a}({\rm CH_2})$	2746 $\nu_{\rm a}({\rm CH_2})$	2949 $\nu_{\rm s}({\rm CH_2})$	2931 $\nu_{\rm s}(*{\rm CH_2})$		
	2975 $\nu_{\rm a}({\rm CH_2})$	2998 $\nu_{\rm s}({\rm *CH_2})$	2988 $\nu_{\rm s}({\rm ^*CH_2})$	2994 $\nu_{\rm a}({\rm CH_2})$	2985 $\nu_{\rm a}({\rm CH_2})$		
	3038 ν_a (*CH ₂)	3078 ν_a (*CH ₂)	3061 ν_a (*CH ₂)	$3018 \nu_a(*CH_2)$	3038 ν_a (*CH ₂)		



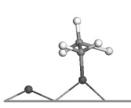


Figure 11. Optimized structure, with top and side views, of ClCH₂-CH₂O- adsorbed at the Cu(100) hollow site with an adjacent oxygen atom

matched infrared bands obtained experimentally and theoretically, as shown in Table 3. In this ClCH₂CH₂O— adsorption geometry, the three vibrational modes for 847, 1021, and 1060 cm⁻¹ all have nonzero dynamic dipole moments perpendicular to the surface that allow the bands to be measured.

The effect of coadsorbed oxygen atoms on the ClCH₂CH₂Oadsorption geometry and infrared absorption frequencies was investigated as well. The preferred oxygen adsorption site was first determined theoretically. It is found that an isolated oxygen atom bonded at the hollow site of Cu(100) has an energy 38.0 and 59.2 kcal·mol⁻¹ lower than the one bonded at bridging and atop sites, respectively. The previous study reported that oxygen atoms were preferentially adsorbed on the hollow sites of Cu-(100), using high-resolution electron energy-loss spectroscopy.³² Therefore, in the investigation of the oxygen effect, the oxygen atoms are assumed to be bonded at the 4-fold hollow sites. Our theoretical calculations, through the search of the fully optimized bonding structure with the minimum total energy of ClCH₂-CH₂O- on O/Cu(100), predict that the most stable ClCH₂-CH₂O – adsorption position is the hollow site in the proximity of a hollow-site oxygen atom. The structure of the ClCH2-CH₂O- bonded at a hollow site next to an atomic oxygen is shown in Figure 11. The calculated infrared bands and detailed structural information of the ClCH₂CH₂O- are shown in the last columns of Tables 3 and 2, respectively. In both cases of hollow-site ClCH₂CH₂O – with and without an adjacent oxygen atom, the theoretical results show similar infrared frequencies and adsorption geometries. On clean Cu(100), only a few percent of monolayer ClCH₂CH₂OH decomposes, similar to the case of C₂H₅OH.^{5,6} Most of the surface ClCH₂CH₂OH molecules are desorbed at 213 K. Note that the C-Cl bond scission temperature of alkyl chlorides on Cu(100) is higher than 236 K.1 It suggests that ClCH2CH2OH dissociates via O-H bond scission preceding the C-Cl bond, generating C2H4 as a desorption product. In contrast to the case of ClCH2CH2OH, BrCH₂CH₂OH (≤ 2 L) on Cu(100) dissociates at ~ 190 K to generate -CH2CH2O-.31 The bond energies of C-Br and C-Cl are approximately 70 and 85 kcal·mol⁻¹, respectively. Bromopropane decomposes readily on Cu(100) at 180 K, forming propyl groups on the surface. The C-X bond energy is a dominant factor controlling the reaction pathways of XCH₂- CH_2OH on Cu(100). The reactions of XCH_2CH_2OH (X = F, Cl, Br, and I) on Ru(111) have been investigated.³³ The reaction routes and product distribution are dependent on the nature of carbon-halogen bonds. CICH₂CH₂OH decomposes on Ru(111) to form CH₄, H₂, and CO₂. In the case ClCH₂CH₂OH/Cu(100), the C-C bond remains intact in the TPR/D studies. On O/Cu-(100), ClCH₂CH₂OH dissociates via O-H bond scission to form ClCH₂CH₂O-, as identified by the 180 K RAIR spectrum (Figure 9). The carbon-halogen effect is also seen in the case of O/Cu(100). BrCH₂CH₂OH dissociates to form -CH₂CH₂O-

on O/Cu(100) at 115 K, although the O-H bonds of alcohol molecules break on O/Cu(100) between 200 and 300 K. 5,6

In the present theoretical studies, it assists in the identification of ClCH₂CH₂O – generated from decomposition on O/Cu(100) and provides the optimized geometry and the most probable adsorption site for this surface intermediate. The calculated difference in the energy for ClCH₂CH₂O – adsorbed at specific surface sites also suggests the directional diffusion barriers that ClCH₂CH₂O – moves on the surface. It is predicted that O and ClCH₂CH₂O- are most likely to be adsorbed at the 4-fold hollow site of Cu(100). There is an implication in the decomposition of ClCH₂CH₂O – on Cu(100). Because the hollow site is the most stable site for O adsorption with an energy 38.0 and 59.2 kcal·mol⁻¹ lower than bridging and atop sites, respectively, from the thermodynamic point of view, ClCH₂-CH₂O is likely to dissociate by breaking the C-Cl and C-O bonds to form C₂H₄ at the hollow site. However, dynamic investigations are needed to understand the reaction paths, especially in the transition state.

Conclusions

The combined results of RAIRS and TPR/D studies show that ClCH₂CH₂OH on Cu(100) is mainly adsorbed reversibly, with a minor decomposition pathway to form ethylene. The molecular orientation of adsorbed ClCH₂CH₂OH molecules can change with surface temperature. However, on oxygen-preadsorbed Cu(100), all of the ClCH₂CH₂OH molecules below a 0.5 L exposure completely dissociate, forming ethylene and acetaldehyde. RAIRS and density functional theory calculations indicate that ClCH₂CH₂OH decomposes on O/Cu(100) via a ClCH₂CH₂O— intermediate, which is most likely to be adsorbed at the 4-fold hollow site. The computational study suggests that in the case of both O and ClCH₂CH₂O— adsorbed at hollow sites next to each other, ClCH₂CH₂O— has a similar bonding geometry and infrared band frequencies to those of ClCH₂CH₂O— in the absence of O.

Acknowledgment. The work was supported by the National Center for High-Performance Computing and the National Science Council of the Republic of China (NSC 93-2113-M-006-010).

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